	Type	L#	Hits	Search Text	DBs	Time Stamp
1	BRS	L1	507	<pre>inspect\$ and semiconductor\$ and microscope and laser</pre>	USPAT; EPO; JPO; DERWEN T; IBM TDB	; · - ·
2	BRS	L2		laser same (ultraviolet or	USPAT; EPO; JPO; DERWEN T; IBM TDB	
3	BRS	L8	1420	(pulsed near6 laser) same (ultraviolet or ultra-violet or uv)	USPAT; EPO; JPO; DERWEN T; IBM	
4	BRS	L14	14	1 and 8	USPAT; EPO; JPO; DERWEN T; IBM TDB	. — —
5	BRS	L21	0	i de la companya de	USPAT; EPO; JPO; DERWEN T; IBM TDB	. — ·
6	BRS	L27	0	2 and 20	USPAT; EPO; JPO; DERWEN T; IBM TDB	. — —

	Type	L #	Hits	Search Text	DBs	Time Stamp
7	BRS	L20	87	diffus\$ same (rotating near8 (opposite or differen\$0 near5 direction))	USPAT; EPO; JPO; DERWEN T; IBM TDB	
8	BRS	L33	1	8 and (rotating near7 diffuse\$)	USPAT; EPO; JPO; DERWEN T; IBM TDB	
9	BRS	L39	1	"3430048".PN.	USPAT	2001/12/20 13:00
10	BRS	L40	1	"3447856".PN.	USPAT	2001/12/20 13:00
11	BRS	L41	1	"3501222".PN.	USPAT	20 0 1/12/20 13:00
12	BRS	L42	1	"3501223".PN.	USPAT	2001/12/20 13:00
13	BRŚ	L43	1	"3633999".PN.	USPAT	2001/12/20 13:01
14	BRS	L44	1	"4053763".PN.	USPAT	2001/12/20 13:04
15	BRS	L45	1	"4264135".PN.	USPAT	2001/12/20 13:04
16	BRS	L46	1	"4511220".PN.	USPAT	20 01 /12/20 13:04
17	BRS	L47	1	"4656358".PN.	USPAT	20 01 /12/20 13:05
18	BRS	L48	1	"4685807".PN.	USPAT	2001/12/20 13:05
19	BRS	L49	1	"4685807".PN.	USPAT	2001/12/20 13:05
20	BRS	L50	1	"4744615".PN.	USPAT	20 01/ 12/20 13:05
21	BRS	L51	1	"5058973".PN.	USPAT	2001/12/20 13:06
22	BRS	L52	1	20 and (homogeniz\$ near6 (illuminat\$ or light))	USPAT; EPO; JPO; DERWEN T; IBM	i 1

	Type	L #	Hits	Search Text	DBs	Time Stamp
23	BRS	L58	42	1 and 2 and pulsed	USPAT; EPO; JPO; DERWEN T; IBM TDB	
24	BRS	L64	19	50	USPAT; EPO; JPO; DERWEN T; IBM TDB	
25	BRS	L65	4288	two near4 diffuse\$	USPAT; EPO; JPO; DERWEN T; IBM TDB	
26	BRS	L71	18	65 and microscope and	USPAT; EPO; JPO; DERWEN T; IBM TDB	

	Type	L#	Hits	Search Text	DBs	Time Stamp
1	BRS	L1	1202	semiconductor\$ and manufactur\$ and (Ultraviolet or uv or ultra-violet) and laser and pulsed	! ·	20 01/ 12/20 1 4:2 6
2	BRS	L8	0		USPAT; EPO; JPO; DERWEN T; IBM TDB	
3	BRS	L14	0	1 and (diffus\$ near10 (rotating or rotatabl\$))	USPAT; EPO; JPO; DERWEN T; IBM	
4	BRS	L 7	•	microscop\$ and (diffus\$ near10 (rotating or rotatable))	USPAT; EPO; JPO; DERWEN T; IBM TDB	: - 1
5	BRS	L21	3	15 and diffus\$	USPAT; EPO; JPO; DERWEN T; IBM	
6	BRS	L1 5	31	(inspect\$ same semiconductor\$) and ((ultraviolet or uv or ultra-violet) and (laser near9 pulsed))	USPAT; EPO; JPO; DERWEN T; IBM	

	Comments	Error Definition	Err ors
1			Ο
2			Ο
3		Truncation Overflow. Return string from Server is: 5`0`0`DIF	1
4		Truncation Overflow. Return string from Server is: 5`0`0`MIC	1
5		Truncation Overflow. Return string from Server is: 5`0`0`DIF	1
6			0